

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention

MAGNETIC RANDOM ACCESS MEMORY AND METHOD OF
FABRICATING THEREOF

Application Number : 10/604533

Confirmation Number: 7-29-03

First Named Applicant: William Wille

Attorney Docket Number: FIS920020132US1

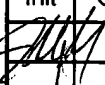

Art Unit: 2813

Examiner:

Search string: (5695810 or 5804458 or 5920500 or 5936293 or 6147900 or 6165803 or 6351408
or 6365419 or 6381170 or 6396735 or 6048739).pn

US Patent Documents

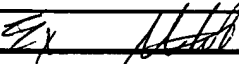
Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5695810	1997-12-09	Dubin, et al.			
	2	5804458	1998-09-08	Tehrani, et al.			
	3	5920500	1999-07-06	Tehrani, et al.			
	4	5936293	1999-08-10	Parkin			
	5	6147900	2000-11-14	Pohm			
	6	6165803	2000-12-26	Chen, et al.			
	7	6351408	2002-02-26	Schwarzl, et al.			
	8	6365419	2002-04-02	Durlam, et al.			
	9	6381170	2002-04-30	Prinz			
	10	6396735	2002-05-28	Michijima, et al.			
	11	6048739	2000-04-11	Hurst, et al.			

Signature

Examiner Name

Date



12/10/04

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

AUG 06 2003

Docket Number (Optional)

FIS920020132US1

Application Number

NYA

Applicant(s)

NUETZEL ET AL.

Filing Date

NYA

Group Art Unit

NYA

*EXAMINER
INITIAL

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

L.A. D'Asaro, J. V. DiLorenzo, and H. Fukui; "Improved Performance of GaAs Microwave Field-Effect Transistors with Low Inductance Via Connections Through the Substrate;" IEEE Transactions on Electron Devices, Vol. ED-25, No. 10, October 1978; pages 1218 - 1221.

T. Ishikawa, K. Okaniwa, M. Komaru, K. Kosaki, and Y. Mitsui; "A High-Power GaAs FET Having Buried Plated Heat Sink for High-Performance MMIC's" IEEE Transactions on Electron Devices, Vol. 41, No. 1; January 1994; pages 3 - 9

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.